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Application Number 10/773,950

Filing Date February 6, 2004

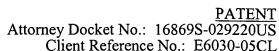
First Named Inventor Takuo Tamura

Art Unit 2818

Examiner Name Dao H. Nguyen

Attorney Docket Number 16869S-029220US

Total Number of Pages in This Submission			Attorney Docket Number	16869S-029220US				
	ENCLOSURES (Check all that apply)							
Fee Transmittal Form Fee Attached Amendment/Reply After Final Affidavits/declaration(s) Extension of Time Request Express Abandonment Request Information Disclosure Statement Certified Copy of Priority Document(s)			Drawing(s) Licensing-related Papers Petition Petition to Convert to a Provisional Application Power of Attorney, Revocation Change of Correspondence Addre Terminal Disclaimer Request for Refund CD, Number of CD(s)	After Allowance Communication to Technology Center (TC) Appeal Communication to Board of Appeals and Interferences Appeal Communication to TC (Appeal Notice, Brief, Reply Brief) Proprietary Information Status Letter Other Enclosure(s) (please identify below): USPTO form SB08A & B (two pages), copies of 6 cited foreign patent and non-patent references, copy of European Search Report for EP01305976, Return Postcard				
Response to Missing Parts/ Incomplete Application Response to Missing Parts under 37 CFR 1.52 or 1.53								
<u>-</u> .	T		OF APPLICANT, ATTORNE	EY, OR AGENT				
Firm Townsend and Towns								
	ual name George B. F. Ye		Reg.	No. 37,478				
Signatu	ire Marie	18+1	<u> </u>					
Date	1/20/							
	CERTIFICATE OF TRANSMISSION/MAILING							
I heret envelo	I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on the date shown below.							
Typed	or printed name Roger H	ton						
Signat	ure	4		Date 9/30/04				





IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Takuo Tamura et al.

Application No.: 10/773,950

Filed: February 6, 2004

For: THIN FILM TRANSISTOR AND DISPLAY USING THE SAME (AS

AMENDED)

Examiner: Dao H. Nguyen

Art Unit: 2818

INFORMATION DISCLOSURE

STATEMENT UNDER 37 CFR §1.97 and

§1.98

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

The references cited on attached form PTO/SB/08A and PTO/SB/08B are being called to the attention of the Examiner. Copies of the foreign patent and non-patent references are enclosed.

Also enclosed is a copy of the European Search Report for the corresponding European application EP01305976 which cites the listed references. Examiner please note that cited reference 1, U.S. Pat. No. 6,190,949 and cited reference 7, Japanese laid open patent application publication JP10-41234, both claims priority to the same Japanese patent application, JP08-150306 filed May 22, 1996.

It is respectfully requested that the cited references be expressly considered during the prosecution of this application, and the references be made of record therein and appear among the "references cited" on any patent to issue therefrom.

Takuo Tamura et al.

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As provided for by 37 CFR §1.97(g) and (h), no inference should be made that the information and references cited are prior art merely because they are in this statement and no representation is being made that a search has been conducted or that this statement encompasses all the possible relevant information.

This IDS is being filed before the mailing date of the final Office Action or Notice of Allowance.

CERTIFICATION

I hereby certify that each item of information contained in this Information

Disclosure Statement was first cited in any communication from a foreign patent office in a

counterpart foreign application not more than three months prior to the filing of this statement.

Applicant believes that <u>no fee is required</u> for submission of this statement. However, if a fee is required, the Commissioner is authorized to deduct such fee from the undersigned's Deposit Account No. 20-1430. Please deduct any additional fees from, or credit any overpayment to, the above-noted Deposit Account.

Respectfully submitted,

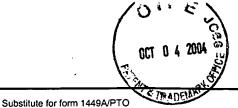
Géorge B. F. Yee Reg. No. 37,478

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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(use as many sheets as necessary)

Sheet of 2

	Complete if Known
Application Number	10/773,950
Filing Date	February 6, 2004
First Named Inventor	Takuo Tamura
Art Unit	2818
Examiner Name	Dao H. Nguyen
Attorney Docket Number	16869S-029220US

U.S. PATENT DOCUMENTS+						
		Document Number				
Examiner Initials*	Cite No. ¹	Number Kind Code ² (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	
	1 .	US-6,190,949	02-20-2001	Noguchi et al.		
	2	US-6,150,203	11-21-2000	Yamazaki et al.		
	3	US-5,981,974	11-09-1999	Makita		
	4	US-5,904,550	05-18-1999	Yamaguchi		
	5	US-5,882,960	03-16-1999	Zhang et al.		
					-	

FOREIGN PATENT DOCUMENTS								
Examiner	Cite	Foreign Patent Document				Name of Patentee or	Pages, Columns, Lines, Where Relevant	
Initials*	No.1	Country Code ³	Number⁴	Kind Code ⁵ (<i>if known</i>)	Publication Date MM-DD-YYYY	Applicant of Cited Document	Passages or Relevant Figures Appear	T ⁶
	6	JP	11-195608	Α	07-21-1999	Hitachi Ltd.		Ø
	7	JP	10-41234	Α	02-13-1998	Sony Corp.	•	Ø
	8	EP .	0598394	A2	05-25-1994	Tokyo Electron Ltd.		
	_			•				

Examiner Signature	Date Considered		

Substitute for form 1449B/PTO

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

10/773,950 Application Number Filing Date February 6, 2004 First Named Inventor Takuo Tamura Art Unit 2818 Examiner Name Dao H. Nguyen

Complete if Known

16869S-029220US

(use as many sheets as necessary)

Attorney Docket Number Sheet

-xammo	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T 2
	9	KURIYAMA et al. "Lateral Grain Growth of Poly-Si Films with a Specific Orientation by an Excimer Laser Annealing Method," Japanese Journal of Applied Physics December 1993, volume 32, pages 6190-6195 (1993).	
	10	KURIYAMA "Excimer laser crystallization of silicon films for AMLCDs," Proceedings of Second International Workshop on Active Matrix Liquid Crystal Displays (AMLCDs '95) September 25-26 1995 Bethlehem, PA (1995).	
	11	KURIYAMA et al. "Lateral Grain Growth in the Excimer Laser Crystallization of Poly-Si," Proceedings of the Materials Research Society Symposium November 1993, volume 321, pages 657-662 (1993).	

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Applicant's unique citation designation number (optional). Applicant is to place a check mark here if English language Translation is attached.